

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of:

Woo Young SO et al.

Serial No. 10/068,004

Group Art Unit: 2826

Confirmation No. 6442

Filed: February 8, 2002

Examiner: Ahmed N. Sefer

For: THIN FILM TRANSISTOR AND MANUFACTURING METHOD THEREOF, AND ACTIVE MATRIX DISPLAY DEVICE AND MANUFACTURING METHOD THEREOF

**APPLICANTS' STATEMENT OF SUBSTANCE OF INTERVIEW**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

On January 4, 2008, the undersigned attorney left a voice mail message for Primary Examiner Ahmed N. Sefer pointing out that the applicants had not yet received a complete Office Action considering the RCE and the Amendment filed on October 31, 2007, and restarting the period for response to replace the incomplete Final Office Action of November 7, 2007, as requested in the Request for Complete Office Action and Restarting of Period for Response filed on December 3, 2007. The attorney requested that the Examiner fax the attorney an Interview Summary indicating that such a complete Office Action will be issued, and that the applicants do not need to take any further action in response to the incomplete Final Office Action of November 7, 2007. On January 4, 2008, the Examiner faxed the attorney a copy of an Interview Summary in which the Examiner states as follows:

No further action is required regarding the final Office Action of 11/7/2007 and a new non final Office Action considering the RCE and the amendment of 10/31/2007 will be issued.

The applicants have now received the original Interview Summary, which was mailed on January 11, 2008. This Applicants' Statement of Substance of Interview is being filed to provide

the statement of the substance of the interview required by the Interview Summary pursuant to MPEP 713.04.

As of the filing date of this paper, the applicants had not received the complete Office Action.

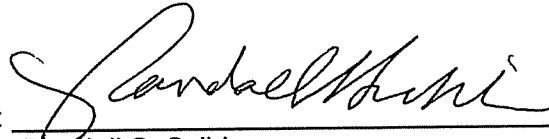
Respectfully submitted,

STEIN, MCEWEN & BUI, LLP

Date: \_\_\_\_\_

01/16/08

By: \_\_\_\_\_



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